

UNITED STATES PATENT AND TRADEMARK OFFICE  
**CERTIFICATE OF CORRECTION**

PATENT NO. : 6,998,156 B2  
APPLICATION NO. : 10/059978  
DATED : February 14, 2006  
INVENTOR(S) : Daniel Bubb et al.

Page 1 of 1

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Column 8:

Lines 58-67,

- 1. A method for transferring a material onto a substrate comprising the steps of:
- (a) directing light of a wavelength in the infrared region which is resonant with a vibrational mode of a target starting material,
  - (b) vaporizing the target starting material with the light without decomposing the target starting material, and
  - (c) depositing the vaporized material on a substrate in solid form that is essentially same chemically as the target starting material. --

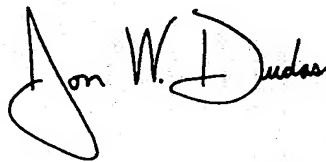
Column 9:

Lines 10-18,

-- 6. The method of claim 1 including the steps of subjecting the target starting material and the substrate to an environment selected from the group consisting of sub-atmospheric, atmospheric and above atmospheric pressure and locating the target starting material and the substrate in the vicinity of each other so that the vaporized material from the target starting material can be deposited on the substrate by free fall; and the temperature of the substrate is such that the vaporized material settles on the substrate and becomes solid. --

Signed and Sealed this

Fifteenth Day of August, 2006



JON W. DUDAS  
*Director of the United States Patent and Trademark Office*